Advanced Transmission Electron Microscopy

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Irradiation dose on the plasma facing components of the future fusion reactor is high:

- Fission reactor: ~1 displacement per atom [dpa] per year (Gen. I), 300°C
- Fusion reactor: ~30 dpa per year (DEMO), 800°C?
- Radiation induced damage lead to hardening and embrittlement

One key to the fusion reactor is materials: first wall, divertor



FÉDÉRALE DE LAUSANNE



Single crystal pure Ni, unirradiated Deformed in uniaxial tension at 5x10⁻⁵ s⁻¹ Traction axis: <110> Test duration: 3.5 hours, elongation: ~120 %





Single crystal pure Ni, irradiated to 0.1 dpa at RT Deformed in uniaxial tension at 1x10⁻⁴ s⁻¹ Traction axis: <110> Test duration: 2 hours, elongation: ~120 %

Strong impact of radiation

20

40

60

shear strain [%]

80

100



120

140

Ability to predict radiation induced effects ?

e.g. hardening, due to interaction of the defects with dislocations, vector of plasticity:

 $\Delta \sigma = \alpha \ \mu \ b \ [Nd]^{1/2}$

Need for accuracy in the determination of:

- Defect density (N)
- Defect size (d)
- Defect type (α)

While **TEM** remains the only technique to directly observe these defects but it suffers

from two limitations:

1) The size of the radiation induced damage and of the dislocation-defect interaction is at the limit of the TEM resolution (about 1 nm).

2) The time of reactions of defects is generally below the time resolution of the TEM (about 1/10 s).

> Need for proper characterization and modelling of radiation induced damage we have to take advantage of recent advances in TEM



Transmission electron microscopy: a brief history

- 1924: De Broglie associates the notion of wave length to particles
- 1927: Davisson, Gerner and Thomson demonstrate electron diffraction
- 1931: Ruska and Knoll obtain images with the first TEM
- 1933: The resolution of light microscopy is overcome by TEM
- 1936: Scherzer demonstrates that the main lens aberrations cannot be eliminated
- 1938: Von Ardenne builts the first scanning electron microscope
- 1939: First commercial electron microscopes are delivered
- 1941: The first EELS measurement recorded in TEM, by Ruthemann
- 1951: First microanalyzer of X-ray by Castaing
- 1965: Crewe describes the first STEM built at ANL First quantification of the TEM image formation using the contrast transfer function by Hanszen and colleagues
- 1968: First experiments on off-axis holography
- 1980: Decisive progress made on electron tomography
- 1986: Nobel prize to Ruska, Binnig and Rohrer for the TEM
- 1994: First commercial image energy filter in TEM
- 1998: Cs corrector installed on a TEM by Haider et al, 1.3 Å
- 1999: Cs corrector installed on a STEM by Krivanek
- 2003: first commercial TEM with Cs correction
- 2008: improvement in Cs correction, 'TEAM' project, 0.5 Å
- 2009: Cs + Cc correctors, 'TEAM' project
- 2010: 'Low voltage' Cs corrected TEM, 'SALVE' project



TEM spatial resolution

TEM resolution suffers from spherical and chromatic aberrations

Spherical aberration C_s :



d = 0.6 (C₃ · λ)^{1/4} **Resolution:**

The advent of C_s correction end of the 90s, made possible thank to computing power, allowed a quantum leap in spatial resolution :

First Cs corrector in 1998 on a TEM resulted in a resolution of 1.3 Å, starting from a 'conventional' resolution of 2.4 Å. Haider et al, Journal of Electron Microscopy, 48 (1998) 395-405

More recently, an ultimate resolution of just below 0.5 Å was reached, within the 'TEAM' US project that comprises 5 DOE labs. It is the 'TEAM 0.5' Cs corrected TEM at Berkeley NCEM, open to users in 2008.

'TEAM I' : Cs + Cc correction TEM at Berkeley NCEM, 2009



A.I. Kirkland et al., JEOL News 41 (1) (2006) 8-11

nice but the price tag of the 'TEAM 0.5' is 7 M€ ... to be compared to 500 k€ for a conventional TEM



The TEM wheel



Conventional TEM





The TEM wheel





RPP



TEM imaging using diffraction contrast



• 'Weak beam': dark field with weakly excited imaging beam



CONVERGENT WEAK BEAM TECHNIQUE



Simulated WB-TEM g(3.1g) image of an edge dislocation in Cu with convergence angle

thickness oscillations → DEFECTS ARE INVISIBLE at some depths!

Script for TEM JEOL2010: tilting the incident beam allows to achieve a range of conditions around the selected diffraction condition in a single exposure of the photographic negative



A. Prokhodtseva CRPP

ÉCOLE POLYTECHNIQUE FÉDÉRALE DE LAUSANNE

R. Schäublin et al. Ultramicroscopy 83 (2000)

CONVERGENT WEAK BEAM TECHNIQUE

UHP Fe CRPP irradiated at RT with 500 keV Fe ions in situ at JANNuS Orsay







WB **g**(4**g**) image Beam is centered within the objective aperture

Thickness: Defect number density:

∼150 nm 1.2·10²² m⁻³



b

CWB image taken in 11 sec single exposure with the range of conditions from (a) to (b)

Thickness: Defect number density: ~150 nm 1.5·10²² m⁻³





CWBT will be used for more efficient g·b analyses of irradiated samples

A. Prokhodtseva CRPP

TEM imaging using diffraction contrast

Limiting factors in the imaging of small structures:

The objective aperture ?

- Necessary to obtain diffraction contrast,
- But it cuts out higher spatial frequencies.
- Typical objective aperture (for bright field, dark field and weak beam dark field imaging modes) limits the resolution of the microscope to about 6 to 7 Å.
- A new aperture was designed by image simulation, on an MD simulated defect.

• Rectangular in shape, placed perpendicular to the operating diffraction vector g (to avoid taking other g's). It implies that resolution is improved along the long axis of the aperture.



FÉDÉRALE DE LAUSANNI





Fig. 14. SEM micrograph of the apertures cut by FIB in a 15 μ m thick Mo foil with a size of (a) ϕ 40 μ m and (b) 40 \times 100 μ m². Collab. with N. Nita, Sendai Univ.

New objective aperture design:

Improved resolution in diffraction contrast: from 6 Å to 3 Å

Fig. 15. Simulated (a and b) and experimental (c and d) weak beam TEM images, 200 kV, g(6g), {g200}, close to a zone axis <011>, of SFT, obtained with an objective aperture size of (a) 2.8 nm⁻¹, (b) 2.8 × 6.5 nm⁻², (c) ϕ 40 µm, and (d) 40 × 100 µm². Experimental images made in Au quenched in water from the melting temperature.

R. Schaeublin, Microscopy Research and Technique 69 (2006) 305-316

5 nm

Drastic improvement in spatial resolution



13th PFCM & 1st FEMaS, Rosenheim, 09-13.05.2011 Advanced Transmission Electron Microscopy

Experiment





Modified objective aperture holder of TEM JEOL 2010:
Design of a new aperture rotation mechanism allowing orienting the aperture perpendicular to the operating g.
Manufactured by EMS[®] (Bolton, UK), delivered 2011
Its 3 apertures are cut by FIB

(ø 10, ø 20 µm and 20x120 µm²)





How can we further improve on imaging of complex structures ?

TEM BF

EFTEM BF elastic

STEM UHAADF



Model ODS ferritic steel: 83.4Fe, 14Cr, 2W, 0.3Ti with 0.3Y₂O₃ nanoparticles, CRPP EPFL TEM, EFTEM, STEM: JEOL 2200FS @ CIME EPFL Lausanne

- Zero loss energy filtering (elastic imaging) reduces noise, especially in thick regions
- High angle dark field STEM improves imaging: highlights oxides, grain structure



TEM imaging of microstructures



Model ferritic steel: UHP Fe-5Cr, EFDA, for Mössbauer study, S. Dubiel, Cracow TEM, EFTEM, STEM: JEOL 2200FS @ CIME EPFL Lausanne

- Zero loss energy filtering (elastic imaging) reduces noise, especially in thick regions
- High angle dark field STEM improves imaging: highlights grain structure in deformations



Comparing STEM and TEM



TEM



STEM: Hitachi HD2700 Cs corrected, 0.8 Å T. Plocinski WUT TEM: JEOL 2200FS, C. Hébert CIME EPFL

Model ODS ferritic steel: 83.4Fe, 14Cr, 2W 0.3Ti, 0.3Y₂O₃, CRPP EPFL









• Y : yttria (Y₂O₃) Ti and Y : pyrochlore phase (Y₂Ti₂O₇ or Y₂TiO₅) • EFTEM more sensitive to sample thickness



STEM X-ray EDS



 4 particles rich in Cr, in both STEM EDS and EFTEM EFTEM sensitive to diffraction contrast



STEM X-ray EDS



 4 particles rich in Cr, in both STEM EDS and EFTEM EFTEM sensitive to diffraction contrast





- 2 particles rich in Ti, Cr and O in both STEM EDS and EFTEM : Ti-Cr oxide
- large Cr rich particle : with or without oxygen ?
- EFTEM better for light elements than X-ray EDS :





large particle is a Cr nitride



Chemical analysis: comparing STEM X-ray EDS to EFTEM



Sampling: EFTEM does better than STEM EDS when considering acquisition time
 Spatial resolution: considering probe size for STEM, the number of electrons and delocalization at low losses. It is around 5 Å, down to <1 Å in ideal cases (STEM)



Data treatment for chemical composition



Data processing of data cubes using Multivariate Statistical Analysis (MSA):

- Recorded data suffers from imperfections, for instance from the presence of noise due to weak signal and/or to short acquisition times.
- Aim of data processing: enhance some parts of a composite signal at the expense of other (hopefully unwanted) parts.
- MSA looks for the directions in the variable space responsible for the maximum of variance and projects the dataset onto these.

F. Trebbia and N Bonnet, Ultramicroscopy 34 (1990) 165 E. R. Malinowski, Factor Analysis in Chemistry, 3rd Edition, Wiley Ed. 2002



A common MSA method: Principal Component Analysis (PCA)

PCA converts a dataset of correlated variables into another of uncorrelated (orthogonal) variables, called principal components.



PCA performs rotations on the original axes

• Axes of least variance can be disregarded to reconstruct the dataset



Raw EFTEM data cube

Energy loss range: 350-760 eV

Microscope: TEM JEOL 2200FS 200 keV, FEG, in column filter C. Hébert CIME EPFL





Model ODS ferritic steel: 83.4Fe, 14Cr, 2W 0.3Ti, 0.3Y₂O₃, CRPP EPFL



Movie showing images made with an energy loss sliding from 350 to 750 eV, 5 eV wide window



PCA applied to data cubes obtained by EFTEM

PCA applied to EFTEM data cube

Energy loss range: 350-760 eV

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13th PFCM & 1st FEMaS, Rosenheim, 09-13.05.2011

Model ODS ferritic steel: 83.4Fe, 14Cr, 2W 0.3Ti, 0.3Y₂O₃, CRPP EPFL



Movie showing images made with an energy loss sliding from 350 to 750 eV, 5 eV wide window

• with PCA, spectrum quality is largely improved



PCA applied to data cubes obtained by EFTEM

Model ODS ferritic steel: 83.4Fe, 14Cr, 2W 0.3Ti, 0.3Y₂O₃, CRPP EPFL



Elemental map performed on titanium L₃ (456 eV) and L₂ (462 eV) edges a) without PCA, background removal is problematic and leads to noise b) with PCA, image quality is largely improved

notice e.g. the shell structure in the particle above the black feature



PCA applied to data cubes obtained by EFTEM

Model ODS ferritic steel: 83.4Fe, 14Cr, 2W 0.3Ti, $0.3Y_2O_3$, CRPP EPFL



Raw data, energy loss window: 29.8-39.8 eV



PCA treated data, energy loss window: 29.8-39.8 eV

again, with PCA, image quality is largely improved

notice the revealed smallest particles, the facets of the largest particles and the shell structure of the particle in the middle

In principle PCA applies to any other type of data, such as STEM X-ray EDS or EELS maps



3D reconstruction of dislocation structure in Al induced by deformation

141 pictures taken every degree from -70° to +70° double tilt rotation holder **TEM** FEI Tecnai 200 kV **bright field**

Dr. Amuthan Ramar CEN DTU Denmark





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Tomography in TEM allows raising ambiguities due to the 2D projection of a 3D object





3D reconstruction of dislocation structure in Al induced by 20% deformation

141 pictures taken every degree from -70° to +70° HATA® double tilt rotation holder **STEM** FEI® analytical TITAN 200 kV **UHAADF** detector

Dr. Amuthan Ramar CEN DTU Denmark

• Tomography in TEM allows raising ambiguities due to the 2D projection of a 3D object





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TEM in situ experiments

JANNuS experiment

B. Décamps, O. Kaïtasov CNRS Orsay



Experiments performed on ultra high purity ferritic materials in view of validating modelling of radiation damage



Single beam Fe 300 KeV, 1 dpa, RT, on UHP Fe, CRPP Movie accelerated 50x TEM observation condition 200 kV WBDF g(4g) g(110)



ex situ ION IRRADIATION/IMPLANTATION, JANNUS SACLAY

UHP Fe CRPP irradiated at RT to 1 dpa with 24 MeV Fe⁸⁺ 1000 appm He with 2 MeV He⁺

Y. Serruys, P. Trocellier CEA Saclay

TEM prepared by FIB at WUT + 'gentle ion mill'











implanted region

low defects density

T. Plocinski, Warsaw University of Technology



ex situ ION IRRADIATION/IMPLANTATION, JANNUS SACLAY

TEM sample preparation technique problem with the FIB: it creates radiation damage !



L. Veleva, R. Schäublin, A.Ramar, Z. Oksiuta, N. Baluc European Microscopy Congress 2008, Volume 2: Materials Science, Eds. S. Richter and A. Schwedt, Springer-Verlag Publication, Berlin Heidelberg, Germany, (2008) 503-504

- Flash polishing allows removing the radiation damage induced by the Focused Ion Beam preparation.
- TEM reveals the oxide particles embedded in the W matrix.

Other possibility: gentle ion mill = lower energy Ga ions (<2 keV) for the final polishing Could be a solution, depending on the level of details required (5 nm or below)



TEM in situ experiments

In situ heating experiments



Thermal stability of Y₂O₃ oxides in ODS EUROFER97 How about the stability of Y-Ti-O oxides ?

A. Ramar CRPP / V. de Castro, U. Carlos III, Madrid / U. of Oxford



TEM in situ experiments

In situ heating experiments

ODS E'97 yttria + Ti



Thermal stability of Y-Ti-O oxides remains an open question

A. Ramar CRPP / V. de Castro, U. Carlos III, Madrid / U. of Oxford



TEM image simulations



- Preliminary results show large effect of He on the primary damage in Fe
- Interesting correlation with MD simulation
- Very promising experiments in view



Number and size of SIA clusters increase with Heint content
He Stabilizes SIA clusters

G. Lucas, R. Schäublin, Helium effects on displacement cascades in α -iron, J. Phys.: Condens. Matter 20 (2008) 415206

How to validate molecular dynamics simulation results ? ... TEM image simulation



Stacking fault tetrahedra in irradiated copper

Experiments



Multislice TEM image simulation



Simulations





Cu 0.01 dpa RT TEM weak beam g(6g) g = (200)

Molecular dynamics simulation Pair potential method, 100'000 atoms

R. Schäublin, Y. Dai, Y. Osetsky, M. Victoria Institute of Physics Publ. (1998) 173-174

TEM image simulation allows validating MD simulation

on going work with D. Terentyev SCK·CEN Mol on GB in Fe and E. Meslin CEA Saclay on dislocation loops in ferritic material

TEM image simulations

outlook: 4D TEM



Cu 20 keV cascade time evolution (MD + TEM image simulation)

R. Schaeublin, M.-J. Caturla, M. Wall, T. Felter, M. Fluss, B.D. Wirth, T. Diaz de la Rubia M. Victoria Journal of Nuclear Materials 307–311 (2002) 988–992

> DTEM to experimentally observe the displacement cascade



Conclusions

- - -

• Recent advance in TEM techniques is a large benefit for the development of materials for fusion (steels, ODS steels, ODS W, ...)

Cs corrected STEM imaging and chemical mapping Energy filtered TEM High angle dark field STEM imaging Tomography

TEM in situ experiments: Ion implantation at JANNuS, unique in the world heating and straining

Data analysis, TEM image simulations

 Collaborative work across Europe is essential as the cost of acquisition and use of such equipments becomes prohibitive for a single lab

